L Number	Hits	Search Text	DB	Time stamp
4	83	"plasma jet" and (pivot$ or tilt$) and (rotates or rotated)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 09:49
5	1419	"plasma jet" and (wafer or substrate or article)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 09:50
13	182	("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 10:37
21	147	("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 10:39
29	108	(("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 10:44
37	59	((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 11:05
45	29	("plasma jet" and (wafer or substrate or article)) and (levitat$ or float)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:41
53	105	("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 11:10
61	99	(("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not ((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above) or ((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 11:59
69	208	("plasma jet" and (wafer or substrate or article)) and rais$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:00

70	164	(("plasma jet" and (wafer or substrate or article)) and rais$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not (((("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not ((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above) or ((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))))) or (("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) or (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float)) or (((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:01
78	101	(((("plasma jet" and (wafer or substrate or article)) and rais$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not (((("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not ((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above) or ((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))))) or (("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) or (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float)) or (((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above))) and below	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:01
86	101	(((("plasma jet" and (wafer or substrate or article)) and rais$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not (((("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not ((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above) or ((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))))) or (("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) or (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float)) or (((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above))) and (below or underneath)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:01
94	8	(c23c016$.ipc. or c23c014$.ipc. or h011021$.ipc) and (((("plasma jet" and (wafer or substrate or article)) and rais$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not (((("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not ((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above) or ((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))))) or (("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) or (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float)) or (((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above))) and (below or underneath))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:49

102	93	(((("plasma jet" and (wafer or substrate or article)) and rais$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not ((((("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not ((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above) or ((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))))) or (("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) or (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float)) or ((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above))) and (below or underneath)) not ((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc) and (((("plasma jet" and (wafer or substrate or article)) and rais$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not ((((("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) not (((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above) or ((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))))) or (("plasma jet" and (wafer or substrate or article)) and suspend$ not (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float))) or (("plasma jet" and (wafer or substrate or article)) and (levitat$ or float)) or ((((("plasma jet" and (wafer or substrate or article)) and (gas near3 (conduits or channels or pipes))) not (("plasma jet" and (wafer or substrate or article)) and (gas near3 inject$))) and below and above))) and (below or underneath)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:21
110	16861	(substrate or article or wafer) and (levitat$ or float or suspend$) and plasma	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:43
118	3549	((substrate or article or wafer) same (levitat$ or float or suspend$)) and plasma	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:44
126	382	(c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc) and (((substrate or article or wafer) same (levitat$ or float or suspend$)) and plasma)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:51
134	61	((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc) and (((substrate or article or wafer) same (levitat$ or float or suspend$)) and plasma)) and (jet or nozzle)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB; USOCR	2002/04/02 12:53